



PATENT

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September 4, 2003

Ayesha S. Wilks

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Michael Nuttall and
Garry Anthony Mercaldi

Attorney Docket No.: 500803.02

Serial No. : 10/075,640

Group Art Unit : 2818

Filed : February 13, 2002

Examiner : David Vu

Title : METHOD FOR ENHANCING VERTICAL GROWTH DURING THE SELECTIVE FORMATION OF SILICON, AND STRUCTURES FORMED USING SAME

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop RCE
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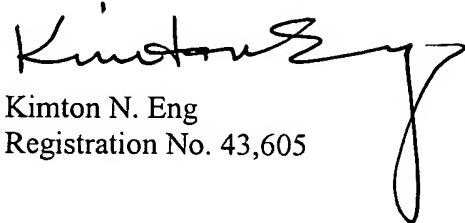
Sir:

In accordance with 37 C.F.R. §§ 1.56 and 1.97 through 1.98, applicants wish to make known to the Patent and Trademark Office the references set forth on the attached form PTO-1449. This application relies, under 35 U.S.C. § 120, on the earlier filing date of prior Application No. 09/770,909, filed January 26, 2001. The references listed on the attached Form PTO-1449 were submitted to and/or cited by the Patent and Trademark Office in this prior application and, therefore, are not required to be provided in this application. If the Examiner wishes, copies will be provided upon request. Although the aforesaid references are made known to the Patent and Trademark Office in compliance with applicants' duty to disclose all information they are aware of which is believed relevant to the examination of the above-identified application, applicants believe that their invention is patentable.

Please acknowledge receipt of this Supplemental Information Disclosure Statement and kindly make the cited references of record in the above-identified application.

Respectfully submitted,

DORSEY & WHITNEY LLP


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KNE:asw

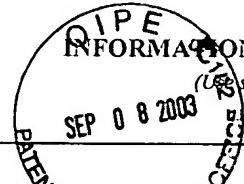
Enclosures:

Postcard
Form PTO-1449

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FORM PTO-1449 (REV.7-80)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. 500803.02	APPLICATION NO. 10/075,640
D I P E INFORMATION DISCLOSURE STATEMENT <i>(use several sheets if necessary)</i>		APPLICANT(S) Michael Nuttall and Garry Anthony Mercaldi	
		FILING DATE February 13, 2002	GROUP ART UNIT 2818



U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AA	5,096,740	03/17/92	Nakagama et al.	427	53.1	
AB	6,172,454 B1	01/09/01	Hofmann	313	495	
AC						
AD						
AE						
AF						
AG						
AH						
AI						
AJ						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AK							
	AL							
	AM							

OTHER PRIOR ART (*Including Author, Title, Date, Pertinent Pages, Etc.*)

AN	Boman, M. et al., "Helical Microstructures Grown by Laser Assisted Chemical Vapour Deposition", Micro Electro Mechanical Systems, February 4-7, 1992, pp. 162-167.
AO	Wallenberger, F.T., "Rapid Prototyping Directly from the Vapor Phase (Laser-assisted Chemical Vapor Deposition)", American Association for the Advancement of Science, March 3, 1995, pp. 1-5.
AP	Westberg, H. et al., "Truly Three Dimensional Structures Microfabricated by Laser Chemical Processing", IEEE, 1991, pp. 516-519.

EXAMINER	DATE CONSIDERED
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* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).